



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/689,958
Filing Date October 20, 2003
Inventor Cem Basceri
Assignee Micron Technology, Inc.
Group Art Unit 2824
Examiner Beth E. Owens
Attorney's Docket No. MI22-2417
Title: Methods of Forming Conductive Metal Silicides by Reaction of Metal with Silicon

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References - See Attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the patents listed on the attached Form PTO-1449. Pursuant to 1276 OG 55, August 5, 2003, no copies of cited U.S. patents or U.S. patent application publications are included, as the date of filing of this patent application occurs after June 30, 2003. No admission is made regarding whether the submitted reference is prior art.

Respectfully submitted,

Dated: 12-27-04

By: 
Mark S. Matkin
Reg. No. 32,268

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. MI22-2417		SERIAL NO. 10/689,958		
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					O P E J C 1 0 1 DEC 27 2004 U. S. PATENT & TRADEMARK OFFICE				
					APPLICANT: Cem Basceri				
					FILING DATE October 20, 2003		GROUP 2824		
U.S. PATENT DOCUMENTS									
*Examiner's Initials		Document Number	Date	Name		Class	Subclass	Filing Date If Appropriate	
	AA	6,753,618	06/2004	Basceri et al.		257	915		
	AB	5,470,794	11/1995	Anjum et al.		437	200		
	AC	2003/0219942 A1	11/2003	Choi et al.		438	253		
	AD	2004/0245560 A1	12/2004	Pontoh et al.		257	309		
	AE	2004/0245559 A1	12/2004	Pontoh et al.		257	306		
	AF	2004/0046197 A1	03/2004	Basceri et al.		257	296		
	AG	2004/0043228 A1	03/2004	Derderian et al.		428	446		
	AH	2003/0213987 A1	11/2003	Basceri et al.		257	296		
	AI	2003/0205729 A1	11/2003	Basceri et al.		257	200		
FOREIGN PATENT DOCUMENTS									
		Document Number	Date	Country		Class	Subclass	Translation	
	AJ							Yes	No
	AK								
	AL								
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)									
	AM								
	AN								
	AO								
EXAMINER		DATE CONSIDERED							
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.									